

Application Data Sheet

10/568147
IAP200301010 18 FEB 2006

Inventor Information

Inventor One Given Name: Kanshi

Family Name: CHINONE

Middle Name:

Mailing Address Line One: c/o Hitachi Chemcial Co., Ltd., Yamazaki Works,

Mailing Address Line Two: 13-1, Higashi-cho 4-chome,

City: Hitachi-shi,

State or Province: Ibaraki

Postal or Zip Code: 317-0061

City of Residence: Hitachi-shi

State or Province of Residence: Ibaraki

Country of Residence: Japan

Citizenship Country: Japan

Correspondence Information

Customer Number:

38834

Name Line One:

Westerman, Hattori, Daniels & Adrian, LLP

Address Line One:

1250 Connecticut Avenue NW- Suite 700

City:

Washington

State or Province:

DC

Postal or Zip Code:

20036

Telephone:

202-822-1100

Fax:

202-822-1111

Electronic Mail:

mail@whdapatentlaw.com

Application Information

Title Line One: POLISHING SLURRY FOR SEMICONDUCTOR PLANARIZATION

Total Drawing Sheets: 1

Docket Number: 062110

Application Type: Utility

Representative Information

Customer No.: 38834

Domestic Priority Information

This application is a: National Stage of

Application One: PCT/JP2004/011549

Filing Date: August 11, 2004

Application Data Sheet

Foreign Priority Information

Foreign Application One: P2003-293438

Filing Date: August 14, 2003

Country: Japan

Priority Claimed: Yes

Assignee Information

Name of Assignee: HITACHI CHEMICAL CO., LTD.

Address Line One: 1-1, Nishinshinjuku 2-chome, Shinjuku-ku,

Address Line Two:

City:

State or Province: Tokyo

Country: Japan

Postal or Zip Code: 163-0449